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Date: April 8, 2010 Name: Edward Machado, Reg. No. 58,372 Signature: /Edward Machado/

Attorney Docket No. 10808/206 (ln1231WOUS)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Franz Schuler et al.)	
Serial No.: 10/523,239)	Examiner: Sarah Kate Salerno /
)	Wai-Sing Louie
Filing Date: September 28, 2005)	
)	Group Art Unit No.: 2814
For: SEMICONDUCTOR)	Confirmation No.: 6476
COMPONENT WITH TRENCH)	
INSULATION AND)	
CORRESPONDING)	
PRODUCTION METHOD)	

SUBSTANCE OF INTERVIEW

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandra, VA 22313-1450

Dear Sir or Ma'am:

On March 16, 2010, Attorney for Applicants interviewed Examiner Wai-Sing Louie regarding an Advisory Office Action communicated on September 28, 2009 by Examiner Salerno. Attorney for Applicants argued that the Lee and Kawai references do not teach or suggest a gate dielectric layer over the first and second insulation covering layers. Examiner Louie noted that Examiner Salerno had relied on Kawai to provide support for a gate dielectric layer 11; but that in his opinion, Kawai did not

disclose the first and second covering layers. Examiner Louie, therefore, indicated that a further search was required.

Respectfully submitted,

/Edward Machado/
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April 8, 2010
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